

Docket No.: 43890-560

#4
7-23-02
PATENT
10/068025
10/06/02
10/06/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Kunio KISHIMOTO, et al. :
Serial No.: : Group Art Unit:
Filed: February 08, 2002 : Examiner:
For: METHOD AND SYSTEM OF DRYING MATERIALS AND METHOD OF
MANUFACTURING CIRCUIT BOARDS USING THE SAME

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

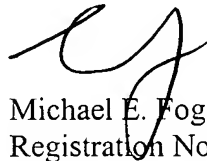
This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Serial No.:

Each non-English language reference was cited in a corresponding foreign application search report or office action and its relevance discussed therein. A copy of the foreign search report or office action, together with an English language version thereof, is attached for the Examiner's information.

Respectfully submitted,

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INFORMATION DISCLOSURE CITATION IN AN APPLICATION (PTO-1449)				ATTY. DOCKET NO. 43890-560		SERIAL NO.	
				APPLICANT Kunio KISHIMOTO, et al.			
				FILING DATE February 08, 2002		GROUP	

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 10/068025
 02/08/02

U.S. PATENT DOCUMENTS						
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	6-268345	9/22/1994	Japan (w/ English Abstract)				
	10-2665	1/6/1998	Japan (w/ English Abstract)				
	61-55372	4/14/1986	Japan (w/ English Abstract)				
	7-243765	9/19/1995	Japan (w/ English Abstract)				
	11-43384	2/16/1999	Japan				
	2000-36666	2/2/2000	Japan (w/ English Abstract)				
	EP0977471A1	2/2/2000	Europe				
	0455465A2	11/6/1991	Europe				

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)	

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.